

WEST Search History

Hide Items | **Restore** | **Clear** | **Cancel**

DATE: Tuesday, April 13, 2004

<u>Hide?</u>	<u>Set</u>	<u>Name</u>	<u>Query</u>	<u>Hit Count</u>
			DB=PGPB,USPT,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR	
<input type="checkbox"/>	L1		((post etch) and (metal lines) and wafer and stripping and ((organic solvent\$) or alcohol\$) and water and ((inert gas) or nitrogen) and immersing and removing and maintaining)	1

END OF SEARCH HISTORY

h e b b cg b chh e f ff e ch e e

Day : Tuesday
 Date: 4/13/2004
 Time: 09:16:52



Inventor Name Search Result

Your Search was:

Last Name = NI

First Name = CHIH-JUNG

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<u>10335294</u>	Not Issued	051	12/31/2002	METHOD FOR REMOVING SI-NEEDLES OF WAFER	NI, CHIH-JUNG
<u>10250038</u>	Not Issued	030	05/30/2003	FLASH MEMORY CELL AND FABRICATION THEREOF	NI, CHIH-JUNG
<u>10063975</u>	Not Issued	030	05/30/2002	METHOD OF SPIKING MIXED ACID LIQUID IN REACTOR	NI, CHIH-JUNG
<u>10057906</u>	Not Issued	071	01/29/2002	CLEAN EQUIPMENT FOR REMOVING POLYMER RESIDUES ON SIDEWALLS OF METAL LINES AND METHOD THEREOF	NI, CHIH-JUNG

Inventor Search Completed: No Records to Display.

Search Another:	Last Name	First Name
Inventor	<input type="text" value="ni"/>	<input type="text" value="chih-jung"/>
	<input type="button" value="Search"/>	

To go back use Back button on your browser toolbar.

Back to [PALM](#) | [ASSIGNMENT](#) | [OASIS](#) | [Home page](#)